Obcket No.: SEPP21.001C1 Customer No.: 20,995

Dbcket No.: SEPP21.001C

AMENDMENT / RESPONSE TRANSMITTAL

Applicant

Tois et al.

App. No.

: 10/678,766

Filed

: October 2, 2003

For

METHOD OF GROWING

OXIDE THIN FILMS

Examiner

: Matthew J. Song

Art Unit,

1765

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

December 28, 2004 (Date)

Andrew N. Merickel, Reg. No. 53,317

Mail Stop Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith for filing in the above-identified application are the following enclosures:

- (X) Response to Office Action in 3 pages.
- (X) Copy of Declaration of Prior Inventorship w/attachments in 6 pages
- (X) Return prepaid postcard.
- (X) Please charge any additional fees, including any fees for additional extension of time, or credit overpayment to Deposit Account No. 11-1410.

Andrew N. Merickel

Registration No. 53,317

Attorney of Record

Customer No. 20,995

(415) 954-4114

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

pplicant : Tois et al.

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Andrew N. Merickel, Reg. No. 53,317

RESPONSE TO OFFICE ACTION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

The present paper is submitted in response to the Office Action mailed on September 28 2004 and is accompanied by a copy of a Declaration of Prior Inventorship Under 37 CFR §1.131 filed in the parent application. Applicants respectfully request consideration of the following Remarks.

Remarks begin on page 2 of this paper.